

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812
Examiner: Stanetta D. Isaac

In Re PATENT APPLICATION of:

Applicant(s): Jun KANAMORI

Serial No.: 10/634,851

Filed: August 6, 2003

For: SEMICONDUCTOR DEVICE
FABRICATION METHOD USING
OXYGEN ION IMPLANTATION

Atty. Docket: MAE 292

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PETITION FOR
THREE MONTH
EXTENSION OF TIMECommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

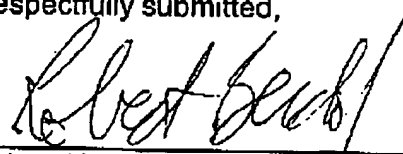
Sir:

It is respectfully requested that the period for replying to the Examiner's Action dated August 25, 2004, be extended for three months under the provisions of 37 C.F.R. 1.136(a).

The applicable extension fee of \$1,020 pursuant to 37 C.F.R. 1.17(a) (3) is submitted herewith.

Should any additional fees be required, please charge the same to our Deposit Account No. 18-0002 and advise us accordingly. A duplicate copy of this paper is enclosed.

Respectfully submitted,

Robert H. Berdo, Jr.
Registration No. 38,075
RABIN & BERDO, PC

Customer No. 23995

Telephone: 202-371-8976 03/04/2005 BBONNER 00000012 10634851

Facsimile: 202-408-0924

February 24, 2005
DateFEE ENCLOSED: \$1,020.00
Please charge any further
fee to our Deposit Account
No. 18-0002

RHB:vm

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